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**CENTRAL FAX CENTER****SEP 09 2004****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****Applicant(s):** Meikei Jeong et al.**Examiner:** Erdem, Fazli**Serial No:** 10/696,634**Art Unit:** 2826**Filed:** October 29, 2003**Docket:** YOR920030394US1 (16963)**For:** CMOS ON HYBRID SUBSTRATE WITH  
DIFFERENT CRYSTAL ORIENTATIONS  
USING SILICON-TO SILICON DIRECT WAFER  
BONDING**Dated:** September 9, 2004**Confirmation No.:** 5489Commissioner for Patents  
United States Patent Office  
Alexandria, VA 23313-1450**RESPONSE UNDER 37 C.F.R. §1.111 AND 1.143**

Sir:

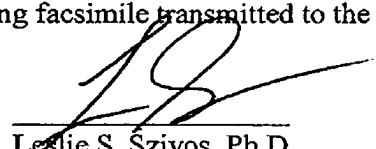
In response to the Office Action dated August 25, 2004, applicants provisionally elect, without traverse, the subject matter of Group I, i.e., Claims 1-9 and 24-35 for continued prosecution in the above-identified patent application.

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**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: September 9, 2004

  
Leslie S. Szivos, Ph.D.

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